Electronic Patent Application Fee Transmittal

Application Number:	10674568
Filing Date:	29-Sep-2003
Title of Invention:	Method and system for monitoring an etch process
First Named Inventor/Applicant Name:	Matthew Fenton Davis
Filer:	Keith Patrick Taboada
Attorney Docket Number:	6716/ETCH/SILICON

Filed as Large Entity

Utility under 35 USC 111(a) Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD($)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Filing a brief in support of an appeal	1402	1	540	540
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD($)
Extension - 1 month with $0 paid	1251	1	130	130
Miscellaneous:				
			Total in USD ($)	**670**